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PATENT  
Serial No: 10/811,984  
Attorney Docket No: 10517/225

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Shigetaka Yoshikawa, *et al.*  
Application No: 10/811,984  
Filed: March 30, 2004  
Group Art Unit: 1723  
Examiner: (To Be Assigned)  
For: MOUNTING STRUCTURE AND METHOD FOR  
HEAT ACCUMULATION TANK

**INFORMATION DISCLOSURE STATEMENT**

**Mail Stop - Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

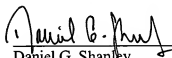
Pursuant to 37 CFR § 1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom. The filing of this Information Disclosure Statement and the enclosed PTO Form No. 1449, shall not be construed as an admission that the information cited is prior art, or is considered to be material to patentability as defined in 37 C.F.R. § 1.56(b). The paragraphs marked below are applicable. It is believed that no fees other than those indicated below are due, but authorization is hereby given to charge any additional fees due, or to credit any overpayment, to deposit account 11-0600.

☒ 1. This Information Disclosure Statement is being filed (a) within three months of the filing date of a national application other than a continued prosecution application under 37 C.F.R. § 1.53(d), (b) within three months of the date of entry of the national stage as set forth in 37 C.F.R. § 1.491 in an international application, (c) before the mailing date of a first Office Action on the merits in the present application, OR (d) before the mailing of a first office action after filing of a request for continued examination. No certification or fee is required.

- ☒ 2. The references were cited in a corresponding foreign application. An English language translation of the Examiner's Comments regarding the Japanese Office Action issued on August 8, 2006 is attached for the Examiner's information.
- ☒ 3. A concise explanation of the relevance of the non-English language reference appears in the Appendix attached hereto.
- ☒ 4. English-language Abstract of the non-English language reference is attached hereto.

Respectfully submitted,

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Substitute for form 1449A/PTO

## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet 1 of 1

### Complete if Known

Application Number	10/811,894
Filing Date	March 30, 2004
First Named Inventor	Shigetaka Yoshikawa, et al.
Group Art Unit	1723
Examiner Name	To be Assigned
Attorney Docket Number	10517/225

### U.S. PATENT DOCUMENTS

Examiner Initials *	Cite No. 1	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code <sup>2</sup> (if known)			
			9-22-1997		
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			

### OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS

Examiner Initials *	Cite No. 1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
/KW/	1	Japanese Language Translation of Japanese Office Communication, Appln. No. 2003-093015 issued August 8, 2006
/KW/	2	English Translation of Examiner's Comments, Japanese Office Communication, Appln. No. 2003-093015 issued August 8, 2006

### FOREIGN PATENT DOCUMENTS

Examiner Initials *	Cite No. 1	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup> - Number <sup>4</sup> - Kind Code <sup>5</sup> (if known)				
/KW/	3	JP 06-213116 A	08-02-1994	Takahashi Nobuo Zojirushi Corp.		

Examiner Signature	/Kimberly Wood/	Date Considered	09/27/2009
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> See Kinds Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04.

<sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.

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